

<b>Notice of References Cited</b>	Application/Control No. 09/785,424	Applicant(s)/Patent Under Reexamination PARK ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,124,911	09-2000	Nakamura et al.	349/113
	B	US-6,081,310	06-2000	Katsuya et al.	349/113
	C	US-			
	D	US-			
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	F	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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**NON-PATENT DOCUMENTS**

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